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PATENT
Attorney Docket No.: SSI-04001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

William Dale Jones

Serial No.: 10/680,783

Filed: October 6, 2003

For: **HIGH-PRESSURE PROCESSING
CHAMBER FOR A
SEMICONDUCTOR WAFER**

) Group Art Unit: 1765

) Examiner:

) **TRANSMITTAL LETTER**

) 162 N. Wolfe Road
Sunnyvale, CA 94086
(408) 530-9700

) Customer No.: 28960

MS: Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313

Sir:

Enclosed please find a Supplemental Information Disclosure Statement, and Form PTO-1449, including copies of the references contained thereon, for filing in the U.S. Patent and Trademark Office.

A \$180.00 check is also enclosed pursuant to 37 C.F.R. § 1.17(p) for filing this Information Disclosure Statement after three months as set forth in 37 C.F.R. § 1.97(c).

You will also find enclosed the associated Transmittals, Electronic Information Disclosure Statements, and United States Patent and Trademark Office Acknowledgment Receipts for the electronically filed Information Disclosure Statement (EFS ID #74421) filed on December 16, 2004.

The Commissioner is hereby authorized to charge any additional fee or credit overpayment to our Deposit Account No. 08-1275. **An originally executed duplicate of this transmittal is enclosed for this purpose.**

Respectfully submitted,
HAVERSTOCK & OWENS LLP

By: Thomas B. Haverstock
Thomas B. Haverstock
Reg. No.: 32,571

Dated: 1-7-05

Attorneys for Applicant

CERTIFICATE OF MAILING (37 CFR 1.11)

I hereby certify that this paper (along with any referred to as being enclosed or encased) is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450

HAVERSTOCK & OWENS LLP
Date: 1/7/05 By: [Signature]



PATENT
Attorney Docket No.: SSI-04001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:) Group Art Unit: 1765
William Dale Jones)
Serial No.: 10/680,783) Examiner:
Filed: October 6, 2003)
For: **HIGH-PRESSURE PROCESSING**) **SUPPLEMENTAL INFORMATION**
CHAMBER FOR A) **DISCLOSURE STATEMENT**
SEMICONDUCTOR WAFER) 162 N. Wolfe Road
) Sunnyvale, CA 94086
) (408) 530-9700
)

MS: Amendments
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313

Sir:

The citations listed below, copies attached, may be material to the examination of the above-identified application, and are therefore submitted in compliance with the duty of disclosure defined in 37 C.F.R. §§ 1.56 and 1.97. The Examiner is requested to make these citations of official record in this application.

United States Patents or Published Patent Applications have been filed electronically (EFS ID #74421). Applicants have become aware of the following printed publication which may be material to the examination of this application:

- Japanese Patent Abstract JP 40 5-283511 A; and
- Japanese Patent Abstract JP 2001-77074.

01/03/2005 EFS/ES 69000074 10830703

01/03/2005

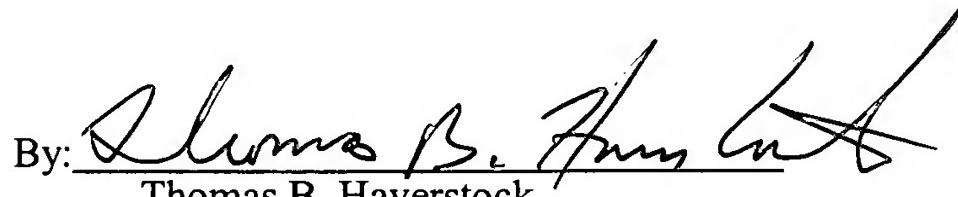
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PATENT
Attorney Docket No.: SSI-04001

This Supplemental Information Disclosure Statement under 37 C.F.R. §§ 1.56 and 1.97 is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that anyone or more of these citations constitutes prior art.

Respectfully submitted,
HAVERSTOCK & OWENS LLP

Dated: 1 - 7 - 05

By: 
Thomas B. Haverstock
Reg. No.: 32,571

Attorneys for Applicant

CERTIFICATE OF SERVICE

I hereby certify that this paper (which will be referred to as "the document" or "this paper") is being filed with the U.S. Patent and Trademark Office on the date shown below with sufficient postage and first class envelope or envelope addressed to the:
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- 2 -

Date: 1/7/05 By: DeG
HAVERSTOCK & OWENS LLP.

**UNITED STATES PATENT AND TRADEMARK OFFICE
ACKNOWLEDGEMENT RECEIPT**

Electronic Version 1.1
Stylesheet Version v1.1.1

Title of Invention	HIGH-PRESSURE PROCESSING CHAMBER FOR A SEMICONDUCTOR WAFER									
Submission Type:	Information Disclosure Statement									
Application Number:	10/680783	*10/680783*								
EFS ID:	74421									
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ICON1	5859									
USPTOEFSNotice	The documents provided in this submission were accepted by the USPTO. However, the fees associated with new utility and provisional Electronic Filing System (EFS) submission were not accepted by our automated systems because the USPTO software has not yet been updated for the fee structure and amounts required by the Consolidated Appropriations Act, 2005, Section 801, of Division B. In due course a corrected fee may be assessed due to changes associated with the Appropriations Act. We will charge the amount indicated in your submission. If at least the basic filing fee accompanied a new utility or provisional EFS submission, then no surcharge based on fee deficiency will be applied when any fee deficiency is paid. For assistance with e-filing a patent application, contact the Patent Electronic Business Center: Toll-Free Number: 1866 217-9197 Website: www.uspto.gov/ebc/									

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12/16/2004

Acknowledgement Receipt

Page 2 of 2

First Named Applicant:	William Jones																										
Attorney Docket Number:																											
Timestamp:	2004-12-16 19:36:37 EDT																										
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File Listing:	<table border="1" style="width: 100%; border-collapse: collapse;"> <thead> <tr> <th style="width: 30%;">Doc. Name</th> <th style="width: 40%;">File Name</th> <th style="width: 30%;">Size (Bytes)</th> </tr> </thead> <tbody> <tr> <td>us-ids</td> <td>SSI04001-usidst.xml</td> <td>2469</td> </tr> <tr> <td>us-ids</td> <td>us-ids.dtd</td> <td>7763</td> </tr> <tr> <td>us-ids</td> <td>us-ids.xsl</td> <td>12026</td> </tr> <tr> <td>package-data</td> <td>SSI04001-pkda.xml</td> <td>1706</td> </tr> <tr> <td>package-data</td> <td>package-data.dtd</td> <td>27025</td> </tr> <tr> <td>package-data</td> <td>us-package-data.xsl</td> <td>19263</td> </tr> <tr> <td></td> <td>Total files size</td> <td>70252</td> </tr> </tbody> </table>			Doc. Name	File Name	Size (Bytes)	us-ids	SSI04001-usidst.xml	2469	us-ids	us-ids.dtd	7763	us-ids	us-ids.xsl	12026	package-data	SSI04001-pkda.xml	1706	package-data	package-data.dtd	27025	package-data	us-package-data.xsl	19263		Total files size	70252
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TRANSMITTAL	
Electronic Version v1.1 Stylesheet Version v1.1.0	
Title of Invention	HIGH-PRESSURE PROCESSING CHAMBER FOR A SEMICONDUCTOR WAFER
Application Number:	10/680783 *10/680783*
Date:	2003-10-06
First Named Applicant:	William Dale Jones
Confirmation Number:	5859
Attorney Docket Number:	

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Submitted by:	Elec. Sign.	Sign. Capacity
Thomas B. Haverstock Registered Number: 32571	/tbh/	Attorney

Documents being submitted	Files
us-ids	SSI04001-usidst.xml
	us-ids.dtd
	us-ids.xls
Comments	

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of Invention	HIGH-PRESSURE PROCESSING CHAMBER FOR A SEMICONDUCTOR WAFER
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Application Number: 10/680783 *10/680783*

Confirmation Number: 5859

First Named Applicant: William Jones

Attorney Docket Number:

Search string: (3623627 or 4426358 or 4574184 or 5374829 or 5474410 or 5879459 or 6048494 or 6062853 or 6089377 or 6406782 or 20010050096).pn.

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

Init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
1	3623627	1969-08-22		Alan S. Bolton			
2	4426358	1984-01-17		Johansson			
3	4574184	1986-03-04		Wolf et al.			
4	5374829	1994-12-20		Sakamoto et al.			
5	5474410	1995-12-12		Ozawa et al.			
6	5879459	1999-03-09		Gadgil et al.			
7	6048494	2000-04-11		Annapragada			
8	6062853	2000-05-16		Shimazu et al.			
9	6089377	2000-07-18		Shimazu			
10	6406782	2000-06-18	B2	Johnson et al.			

US Published Applications

Note: Applicant is not required to submit a paper copy of cited US Published Applications

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<file:///G:/IDS-E-Filed/SSI04001/SSI04001-usidst.xml>

12/16/2004

Init	Cite.No.	Pub. No.	Date	Applicant	Kind	Class	Subclass
1		20010050096	2001-12-13	Costantini et al.	A1		

Signature

Examiner Name	Date
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FORM PTO-1449 (Modified)		JAN 10 2005		U.S. Department of Commerce Patent and Trademark Office		Attorney Docket No.: SSI-04001		Serial No.: 10/680,783	
						Applicants: William Dale Jones			
						Filing Date: October 6, 2003		Group Art Unit: 1765	
U.S. PATENT DOCUMENTS									
Examiner Initials		Serial / Patent Number	Issue Date	Applicant / Patentee		Class	Subclass	Filing Date	
	AA								
	AB								
	AC								
	AD								
	AE								
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FOREIGN PATENTS OR PUBLISHED FOREIGN PATENT APPLICATIONS									
		Document Number	Publication Date	Country / Patent Office		Class	Subclass	Translation	
	AK	JP 40 5283511 A	10/29/93	JP		H01L	21/68	X	
	AL	JP 2001-77074	03/23/01	JP		H01L	21/304	X	
	AM								
	AN								
	AO								
OTHER DOCUMENTS (Including Author, Title, Date, Relevant Pages, Place of Publication)									
	AP								
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	AR								
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	AU								
	AV								
	AW								
	AX								
	AY								
	AZ								
Examiner:					Date Considered:				
EXAMINER:		Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							